

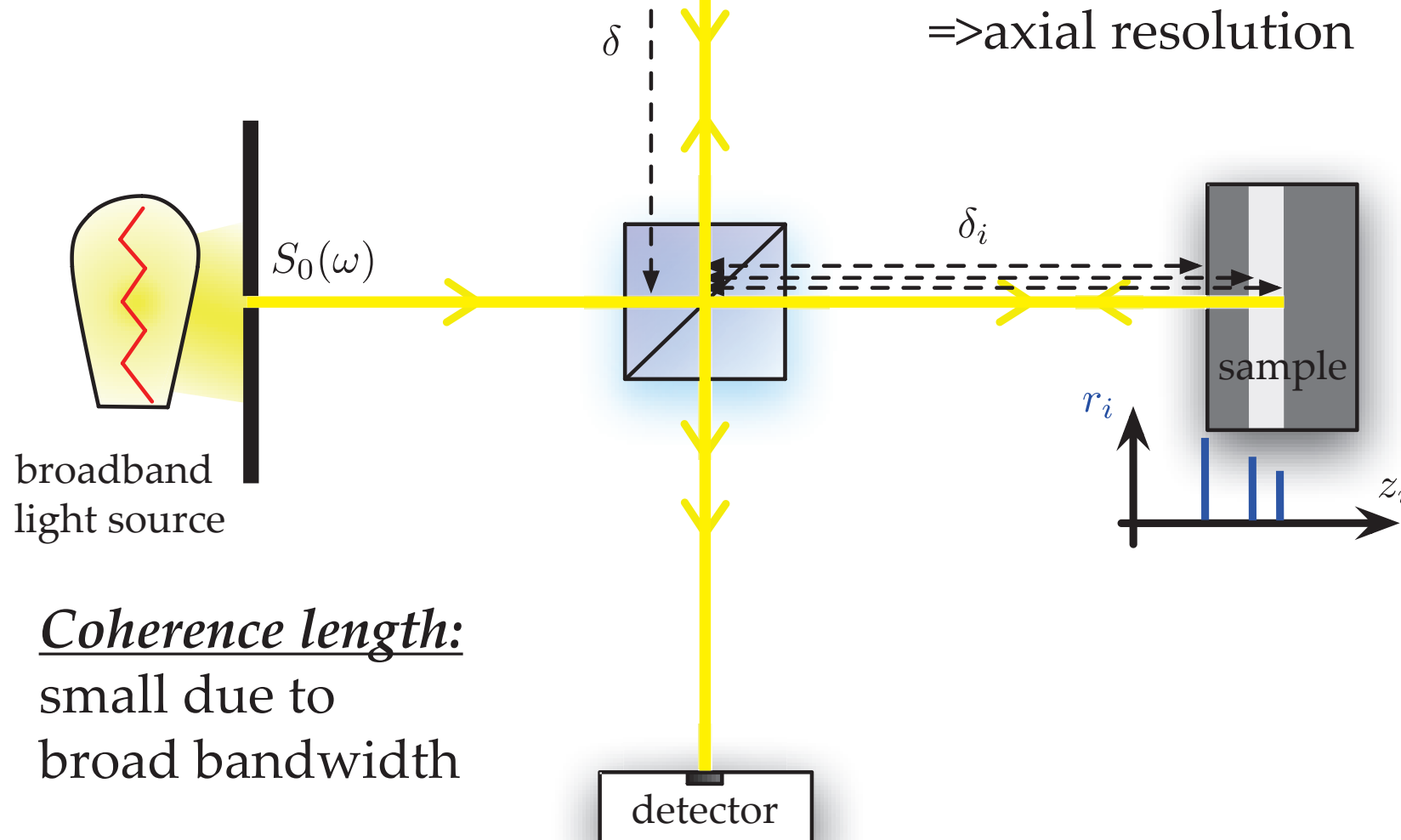
S. Fuchs<sup>1,2</sup>, C. Rödel<sup>1,2</sup>, M. Wünsche<sup>1,2</sup>, A. Blinne<sup>1</sup>, J. Biedermann<sup>1</sup>, U. Zastrau<sup>1</sup>, V. Hilbert<sup>1</sup>, E. Förster<sup>1</sup>, G. G. Paulus<sup>1,2</sup>

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## Introduction: Optical Coherence Tomography

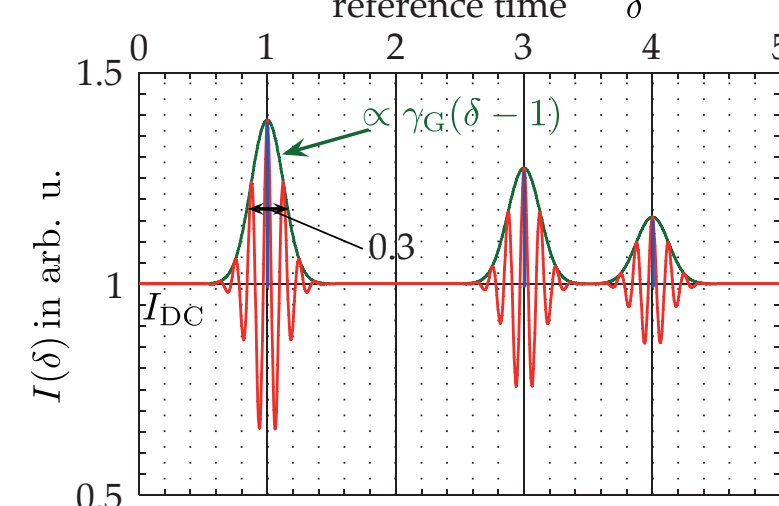
OCT - established technique with broadband IR radiation

**OCT:** based on a Michelson interferometer with a broadband light source [1]



Different OCT methods

**Time-domain OCT:** measuring intensity and moving reference mirror

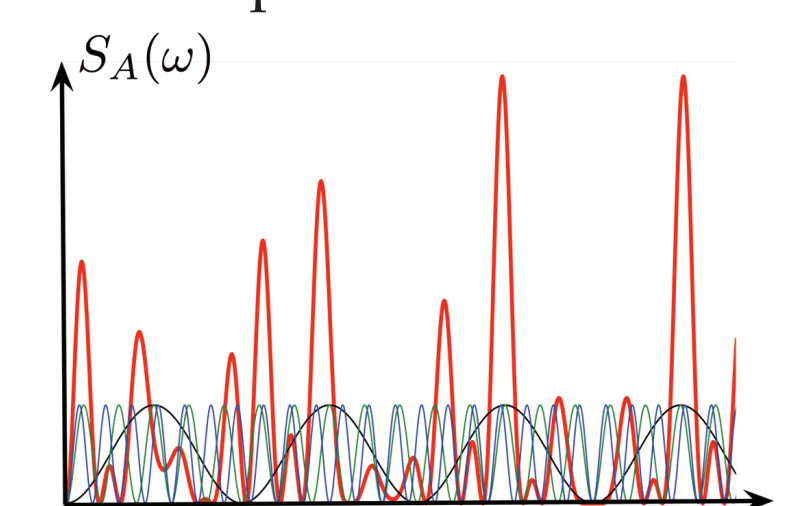


Medical OCT device

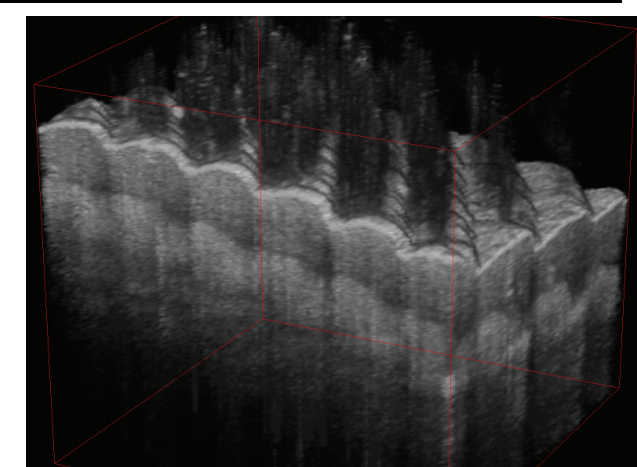


**Wiener-Khinchin**  
FT  $[S_A(\omega)] \propto \gamma(\delta)$

**Fourier-domain OCT:** measuring the reflected spectrum



OCT image of a finger tip



**Resolution:**

few micrometers

**Penetration depth:**

few millimeters [2]

## XUV Coherence Tomography

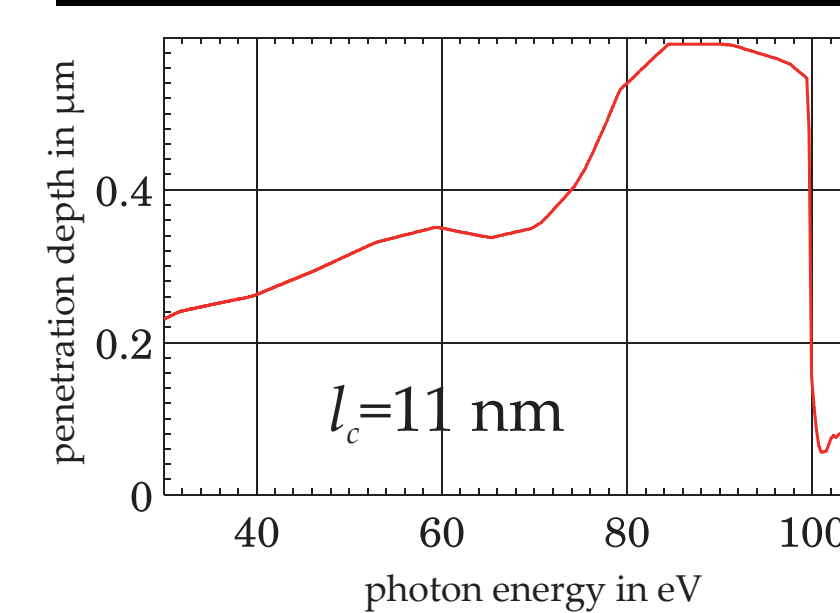
Axial resolution depends on coherence length only

$$l_c = \frac{2 \ln 2}{\pi} \frac{\lambda_0^2}{\Delta \lambda_{FWHM}}$$

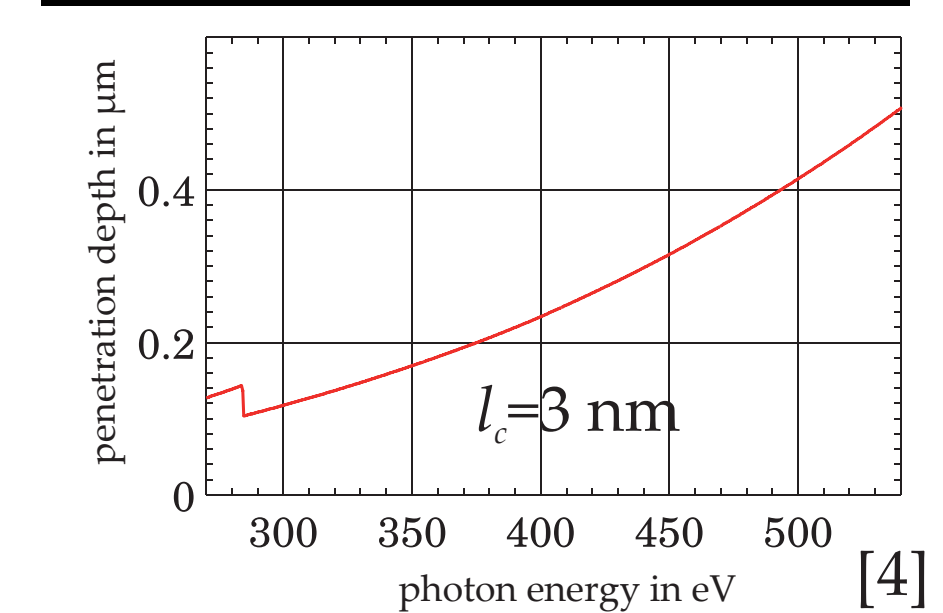
- short wavelengths and broad spectrum lead to high resolution => with XUV-radiation: Nanometer resolution

- strong absorption in the XUV => spectral transmission windows of the sample materials limit the bandwidth and the resolution

**Si-transmission window**



**Water-window**



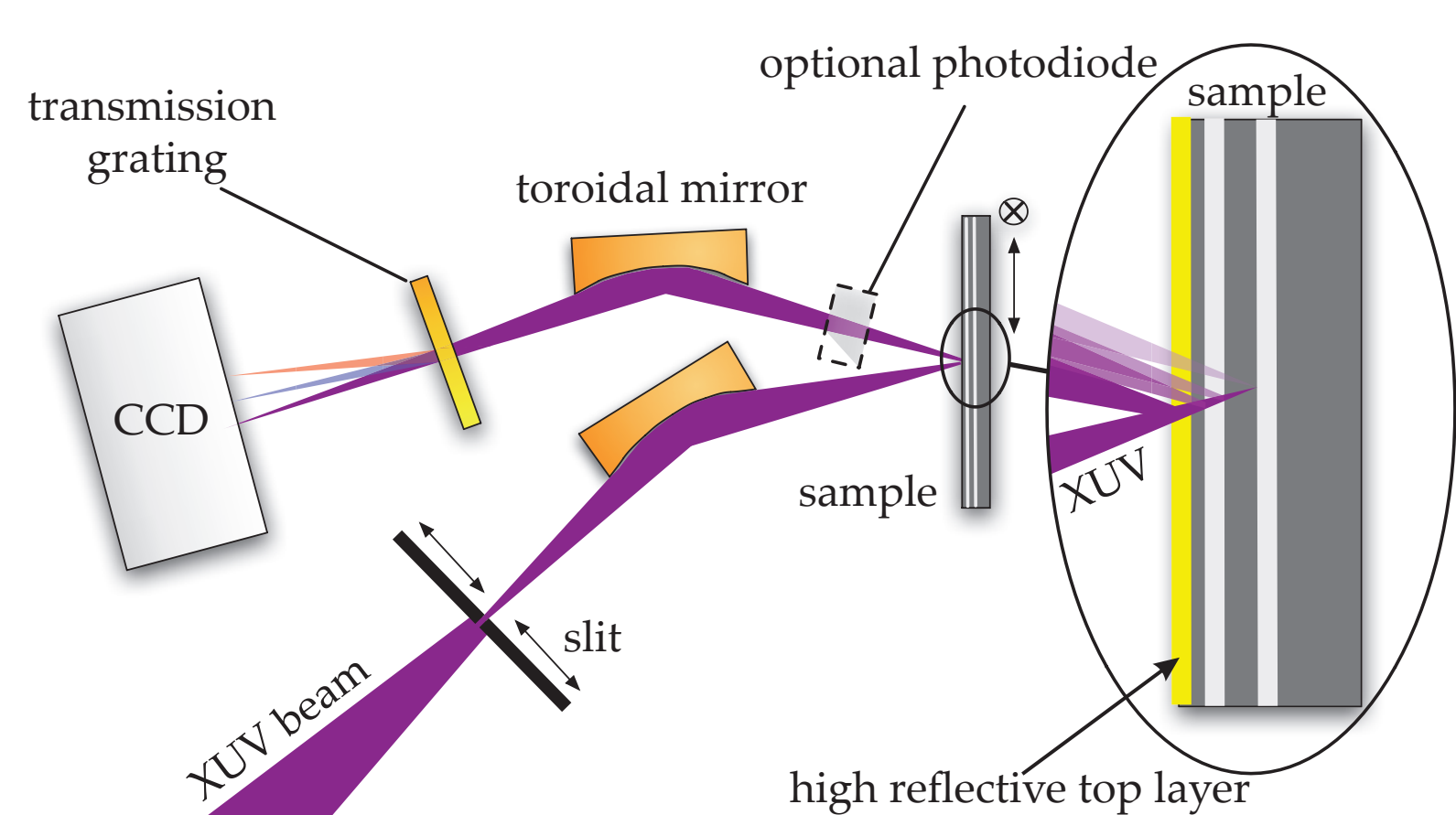
- first experiments were performed at synchrotron radiation sources



## Experimental setup

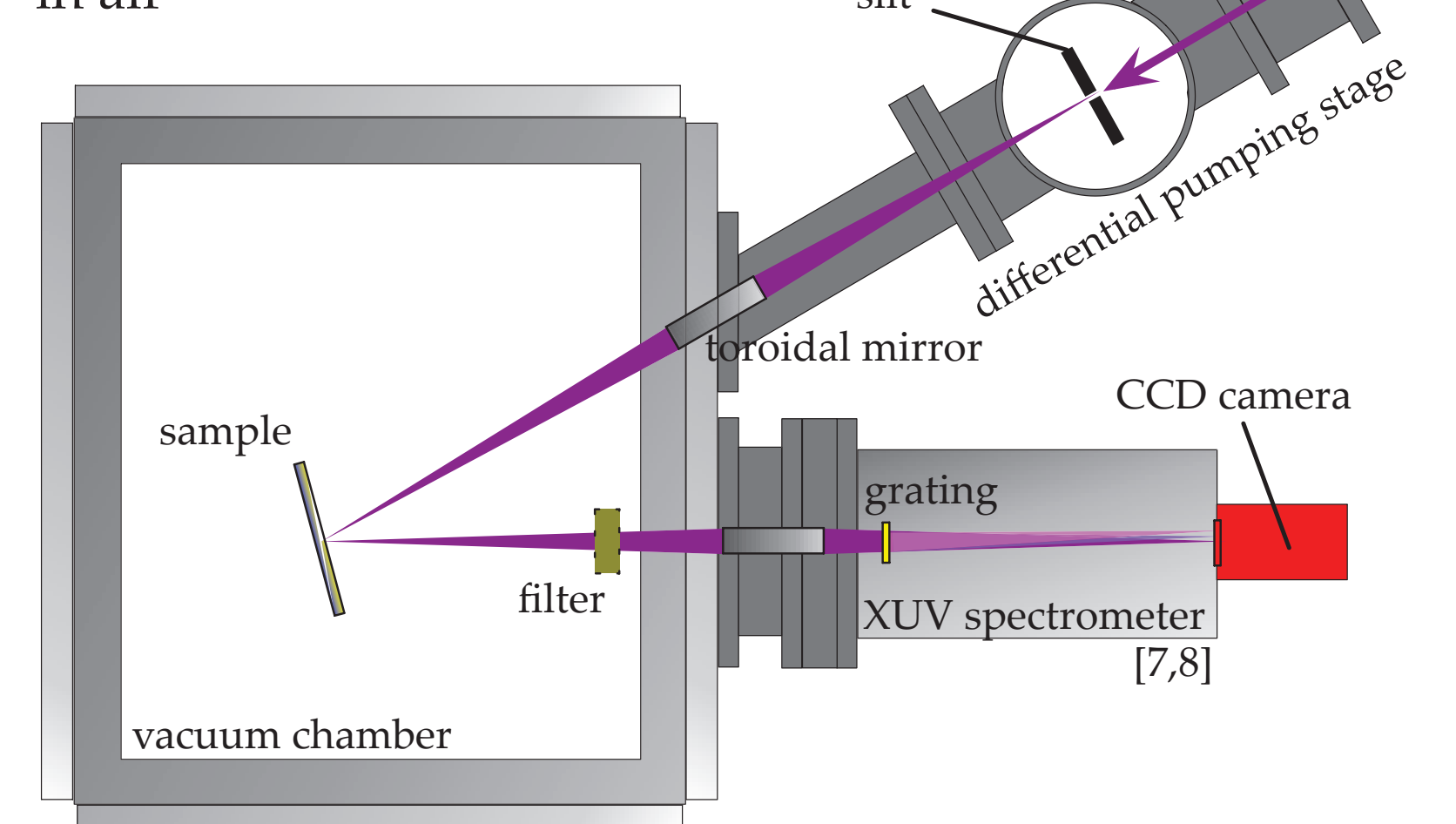
Schematic sketch of the XCT setup

- broadband beam splitter aren't available in the XUV regime [5] => Michelson-based setup not suitable [4,6]
- instead, a Common-Path setup was used
- a high reflective thin top layer replaces the reference mirror [3]



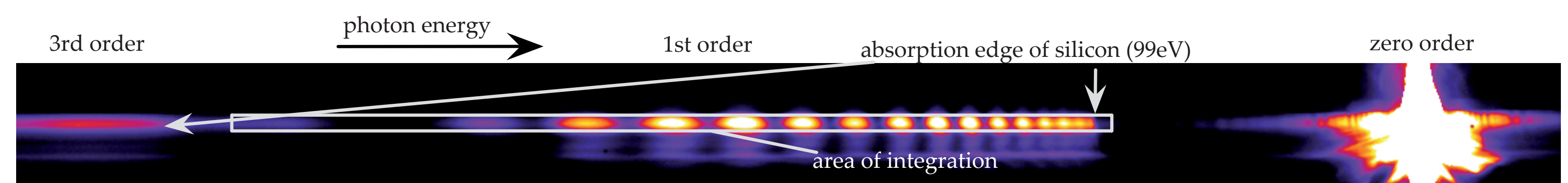
Optics, optical path & vacuum chamber

- whole setup needs to be in vacuum, due to strong absorption of XUV in air

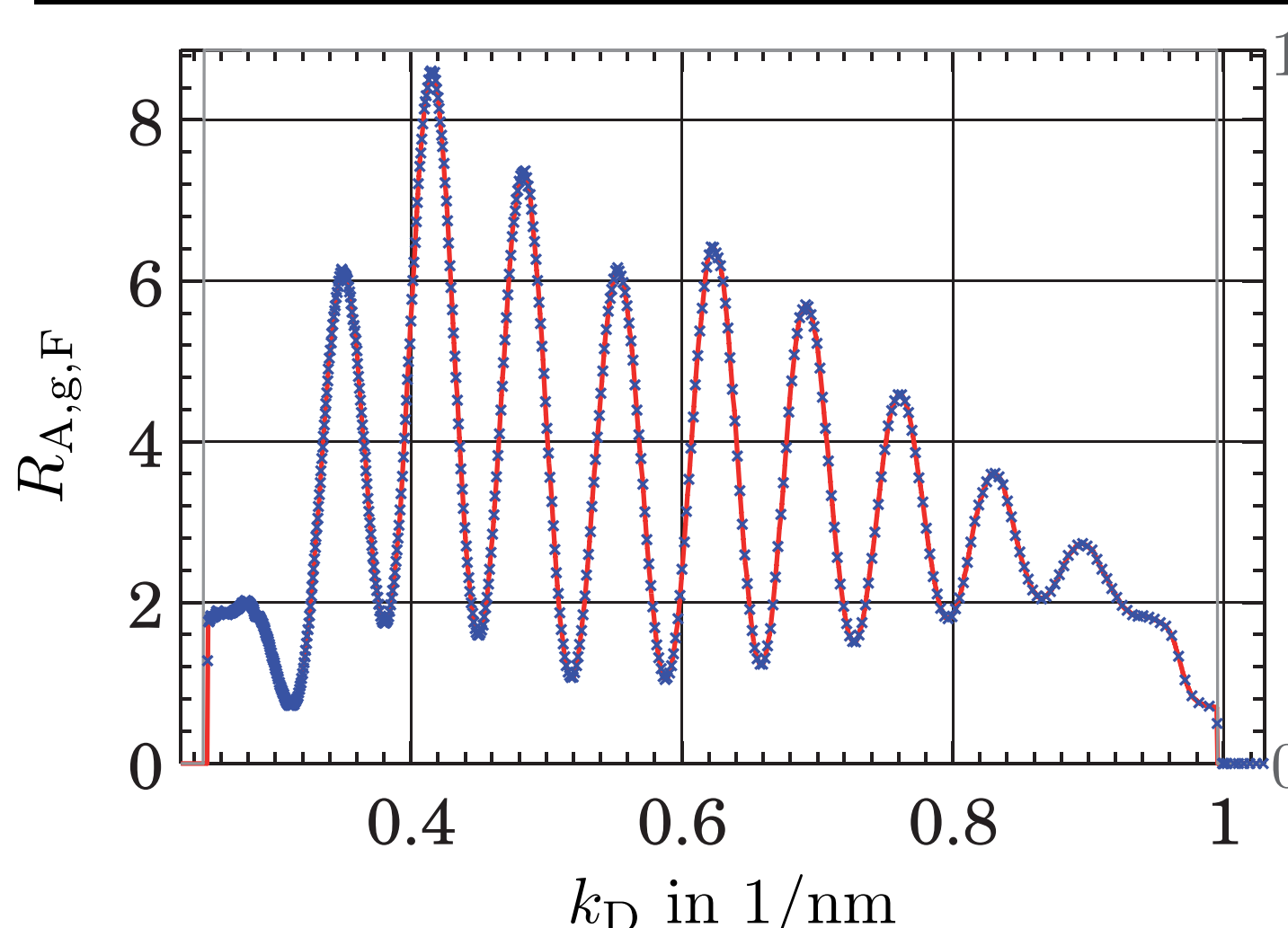


## Experimental results with synchrotron sources

Raw data image: XUV spectrum of a silicon and gold layer system



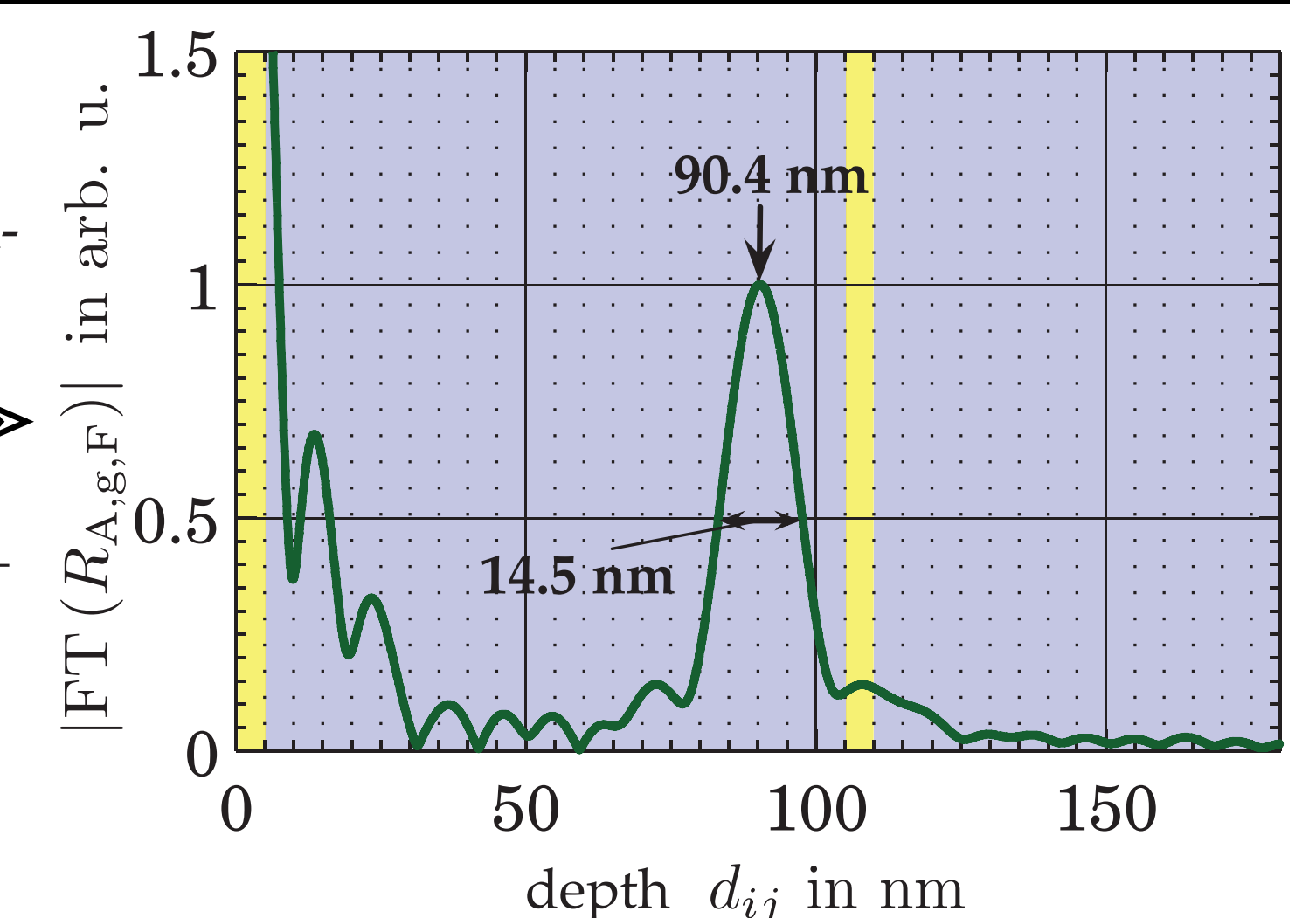
Si- & Au-layers in the Si-transmission window



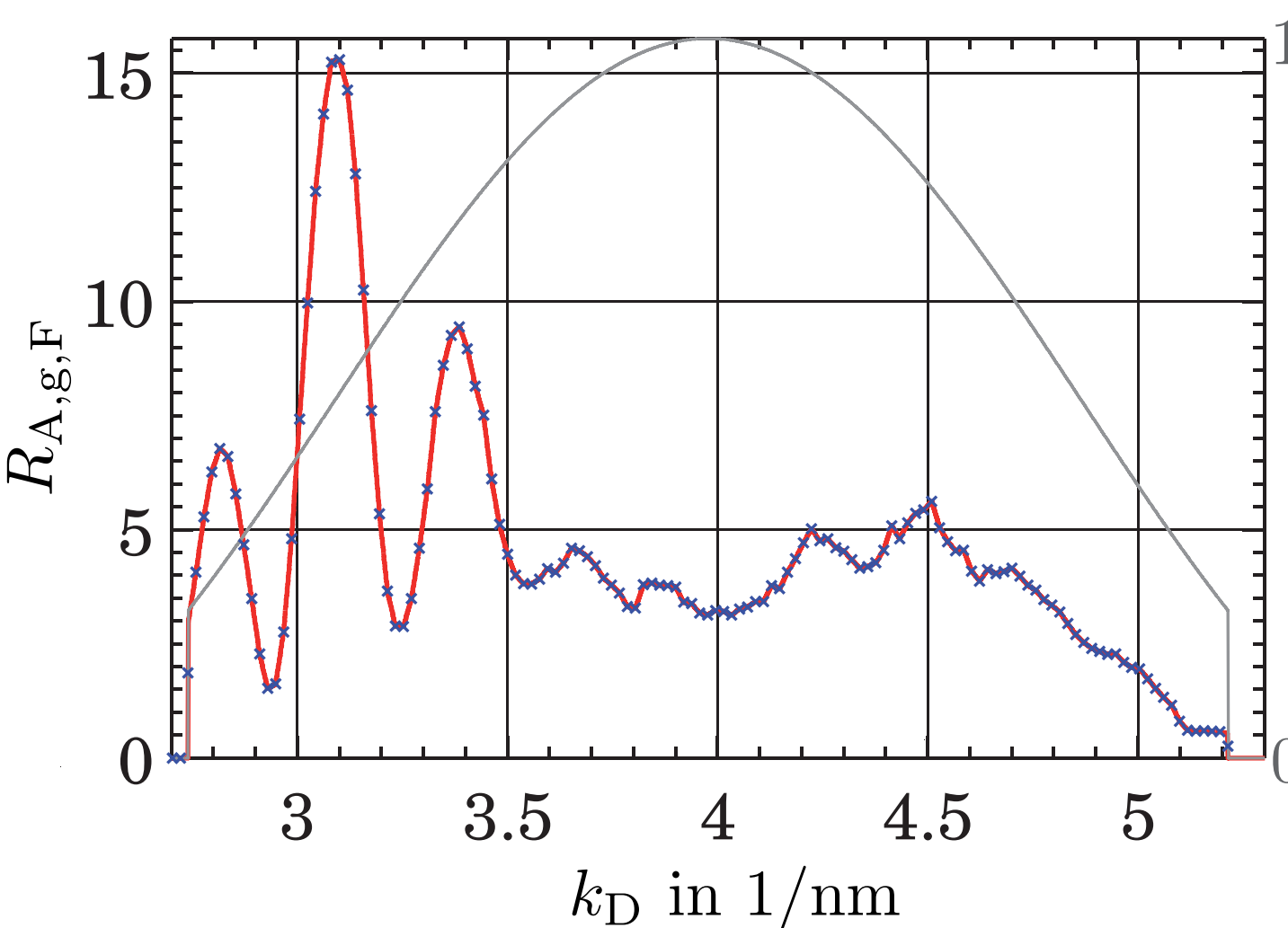
**Raw data:** spectral intensity between 30 and 100 eV depending on the dispersion-corrected wave number

**Fourier-transform**

**Reconstructed depth structure:** Fourier-transform of the spectral intensity



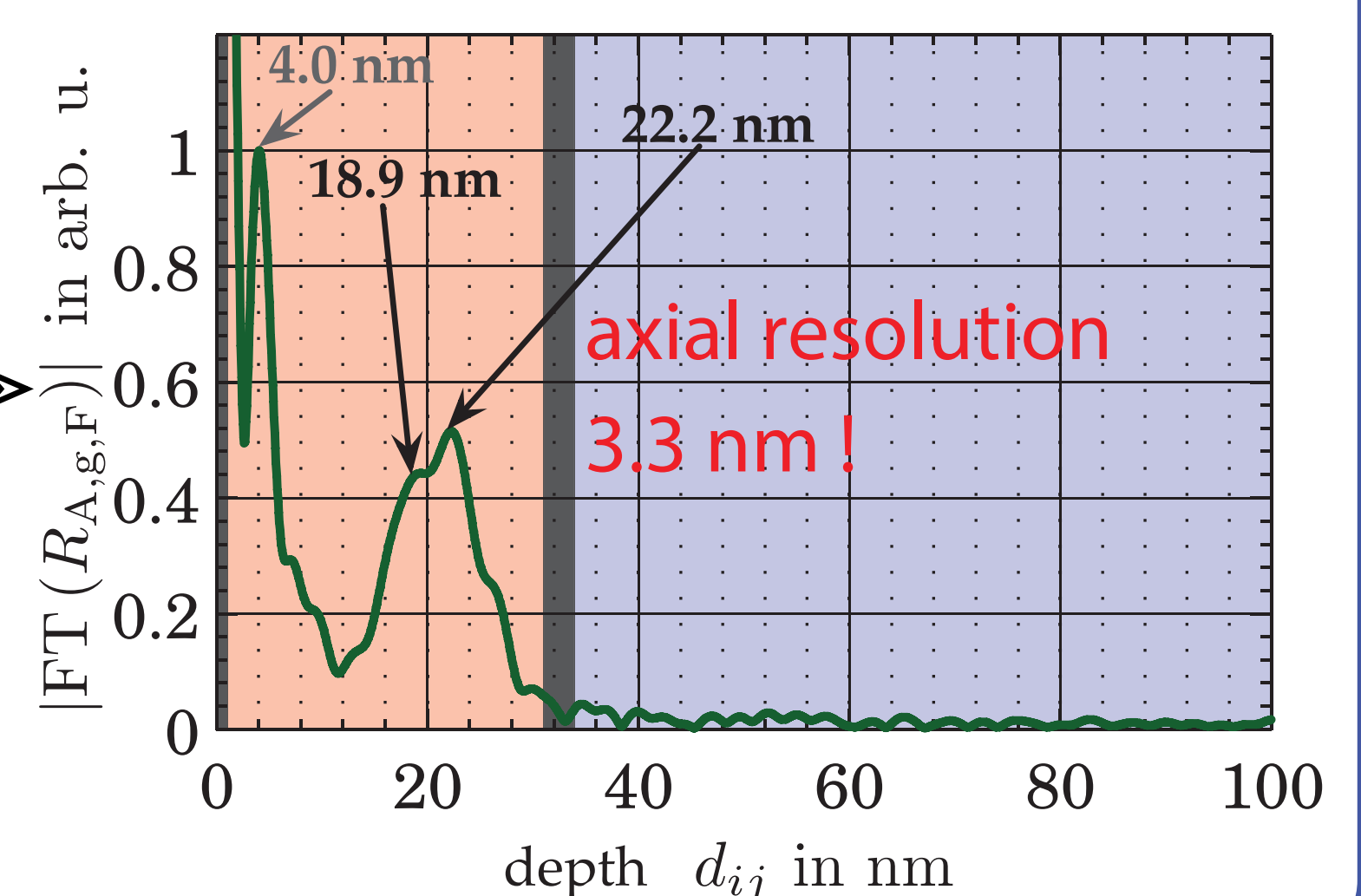
B4C- & Pt-layers in the water-window



**Raw data:** spectral intensity between 280 and 560 eV

**Fourier-transform**

**Reconstructed depth structure:** with 3.3 nm axial resolution

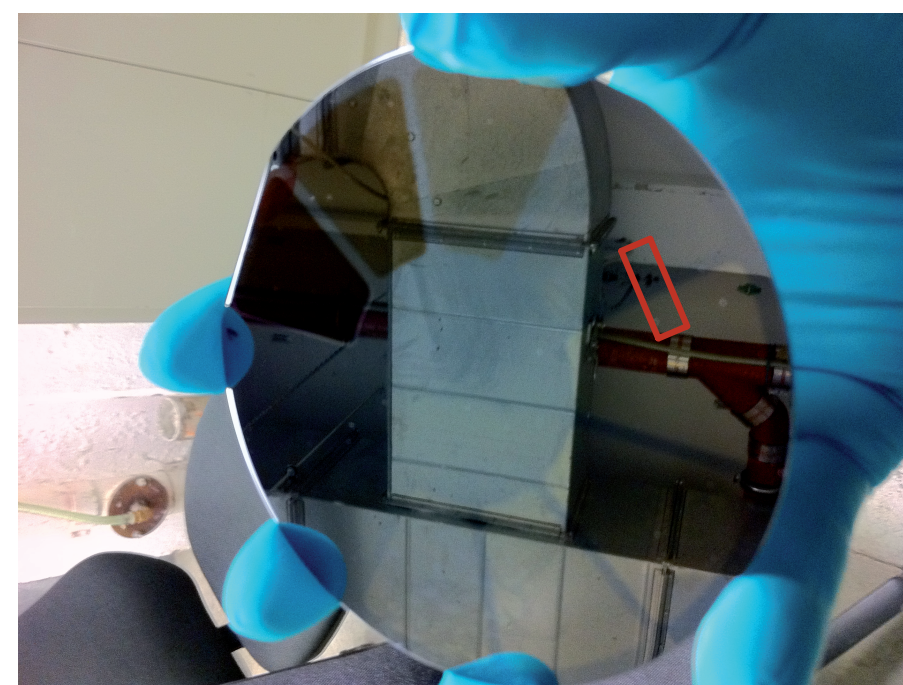
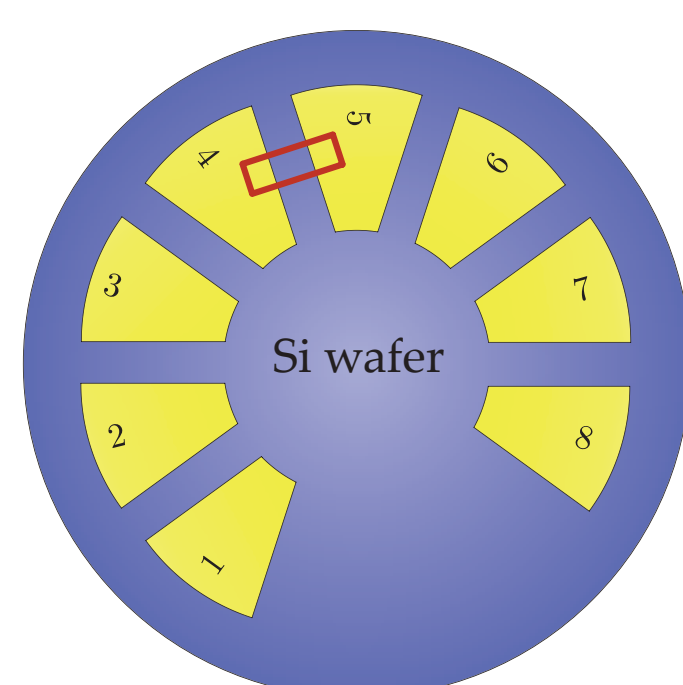
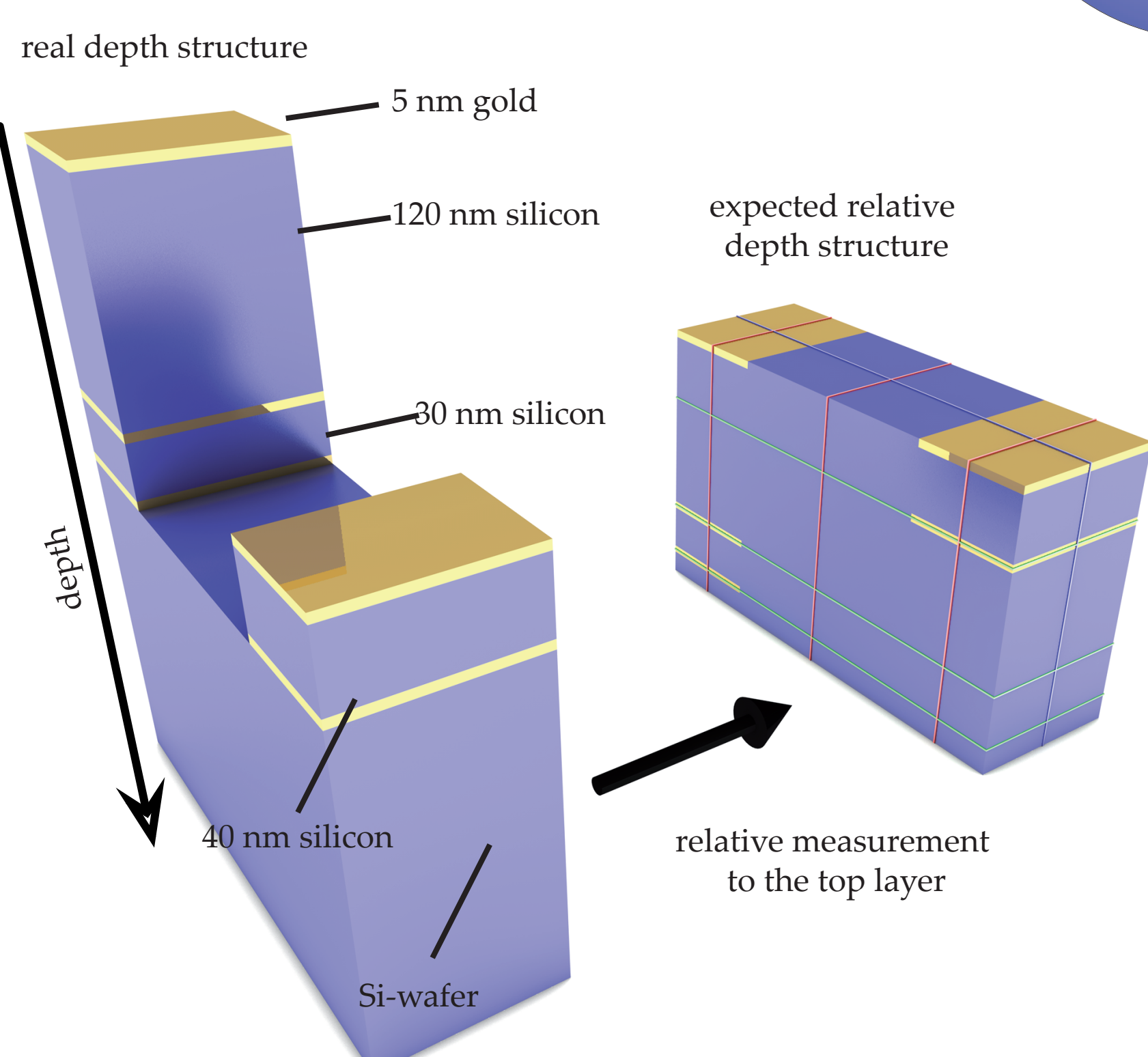


## 3D imaging by lateral scanning

Sample design on Si-wafer

- different layer systems on a Si-wafer
- a volume consisting of different layer systems was imaged by a 3D scan

Schematic sketch of the imaged volume



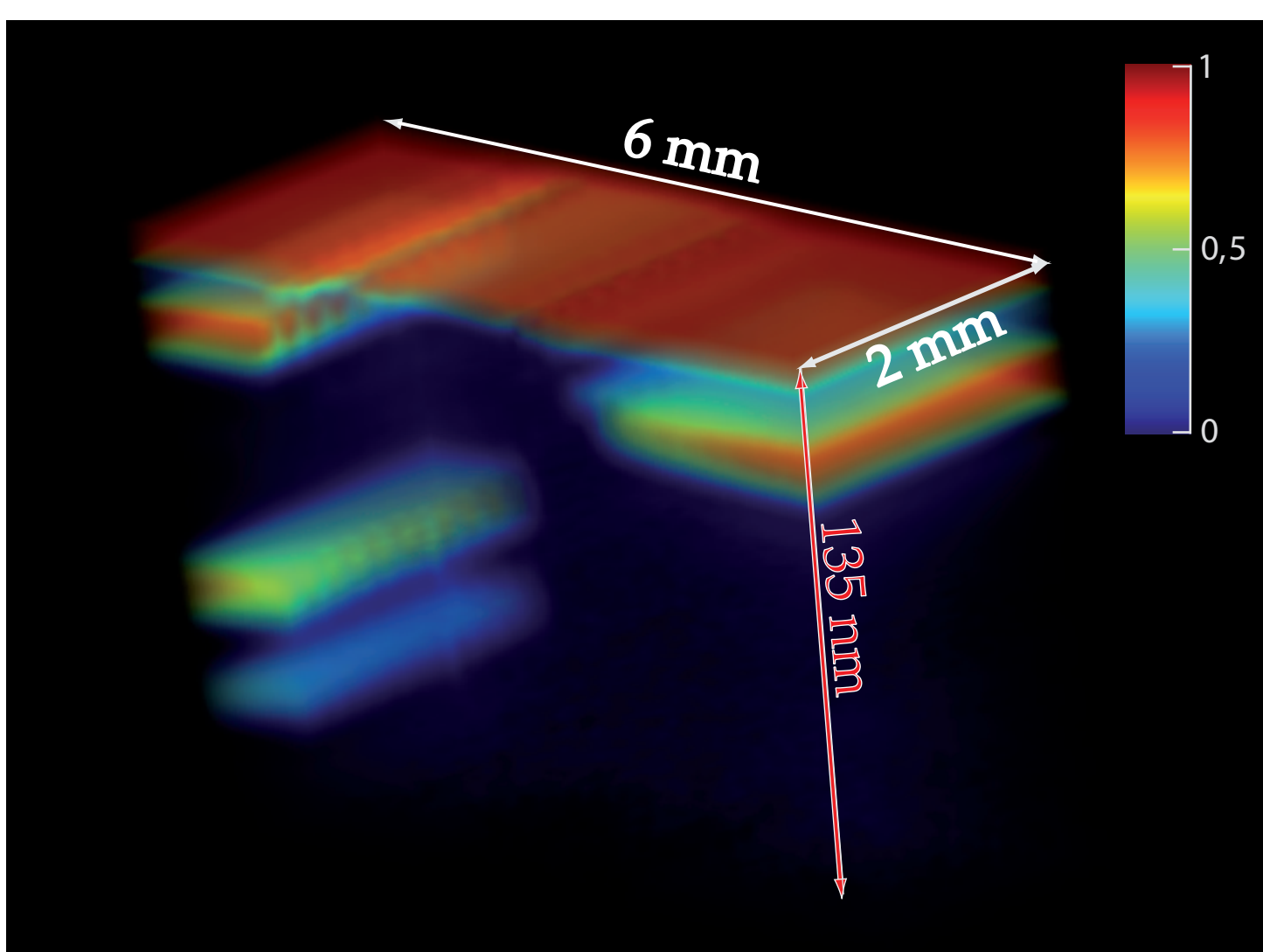
Result of the 3D scan

**resolution:** 12 nm (axial), 200 x 300 μm (lateral, because of the focus size)

**stepwidth:** 100 μm

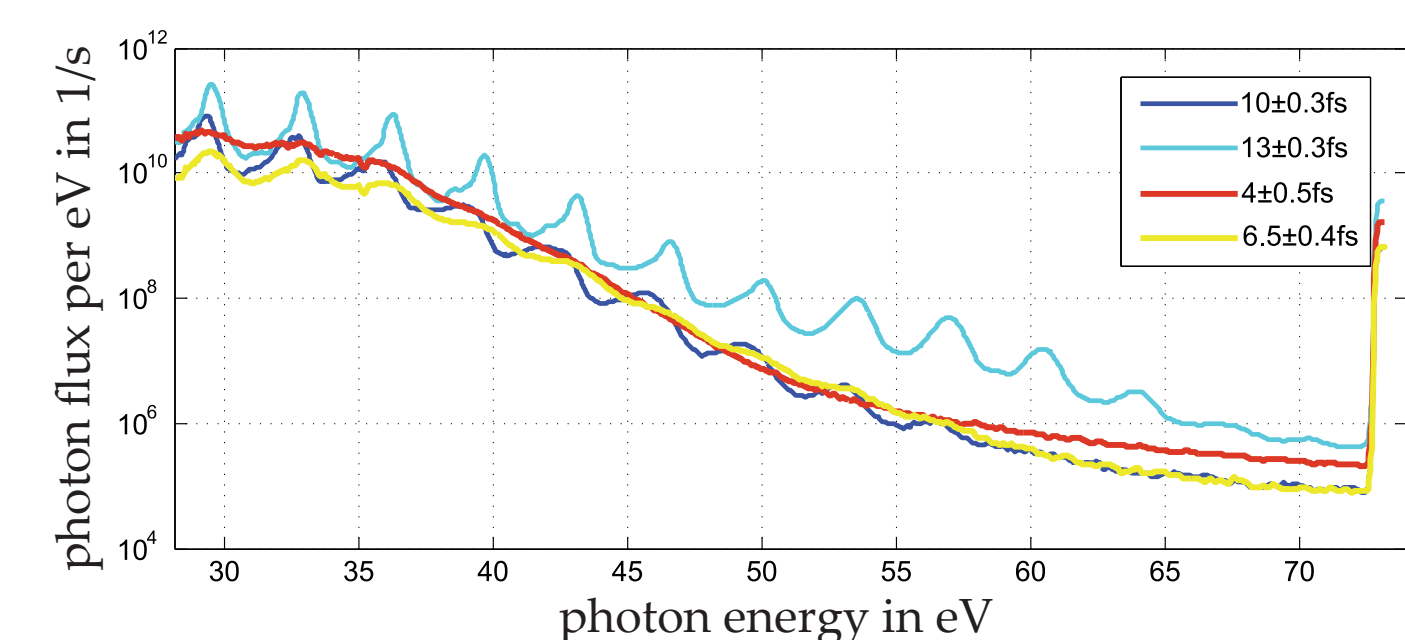
**points of measurement:** 1260

**duration of measurement:** 2.5 h



## Towards XCT with laser-based sources

First results adapting a HHG source for XCT



- HHG with a few-cycle laser system in Argon
- pulse durations below 4 fs lead to isolated attosecond pulses and thus a smooth spectrum which is necessary for XCT

Current limitations

- photon flux 3 orders below synchrotron radiation (10<sup>11</sup> photons/s)
- small bandwidth of 35 eV would reduce the axial resolution of XCT to 40 nm

Road map for further developments

- improving the photon flux by using lasers with higher pulse energy
- using longer wavelengths (>1000 nm) to increase the Cut-Off (~λ<sup>2</sup>) of the harmonic radiation and therefore the effective bandwidth for XCT

References:

- [1] Huang et al.: Optical coherence tomography, Science, 1991
- [2] Leitgeb et al.: Ultrahigh resolution Fourier domain optical coherence tomography, Optics Express, 2004
- [3] Fuchs et al.: Optical coherence tomography using broad-bandwidth XUV and soft-X-ray radiation, Appl. Phys. B, 2012
- [4] Henke, Gullikson, Davis.: X-ray interactions: Photoabsorption, Scattering, Transmission, and Reflection at E=50–30000 eV, Z=1–92, Atomic Data and Nuclear Data Tables, 1993
- [5] Morlens et al.: Study of XUV beam splitter flatness for use on a Michelson interferometer, Laser und Particle Beams, 2004
- [6] Vakhtin et al.: Common-Path Interferometer for Frequency-Domain Optical Coherence Tomography, Appl. Optics, 2003
- [7] Jasny et al.: A single-shot spectrograph for the soft X-ray region, Review of Scientific Instruments, 1994
- [8] Fuchs et al.: Sensitivity calibration of an imaging extreme ultraviolet spectrometer-detector system for determining the efficiency of broadband extreme ultraviolet sources, Rev. Sci. Instrum., 2013

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